

07/25/00
JC882 U.S. PTO
09/625336
07/25/00

07-26-00

Docket No. 004742/AMI-00-07

IN THE UNITED STATES PATENT AND TRADE MARK OFFICE

A

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

Re: Inventor(s): Moris Kori, Alfred W. Mak, Jeong Soo Byun, Lawrence Chung-Lai Lei; and Hua Chung
Title: METHOD AND SYSTEM FOR CONTROLLING THE PRESENCE OF FLUORINE IN REFRACTORY METAL LAYERS

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 15 pages, excluding Title Sheet.
☒ Drawings totaling 11 pages, ___ Formal ☒ Informal.
___ Declaration and Power of Attorney.
___ Assignment of the invention to Applied Materials, Inc.
___ Assignment Recordation Cover Sheet
☒ Information Disclosure Statement and Form 1449 along with copies of (5) five references recited therein

JC882 U.S. PTO
09/625336
07/25/00

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims 20	20	20-20 = 0	0	X \$	--
Independent Claims	4	4 - 3 = 1	1	\$78	\$78
Basic Filing Fee				\$690	\$690
TOTAL FEES					\$768

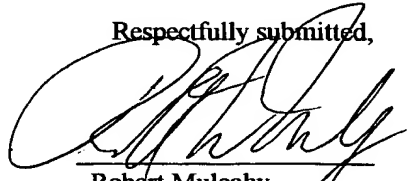
- ☒ The Commissioner is hereby authorized to charge \$768.00 Deposit Account No. 50-1074.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
- ☒ Please address all future correspondence to:
**PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O.BOX 450A
Santa Clara, CA. 95052**

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Box Patent Application, Assistant Commissioner for Patents, Washington, D.C. 20231.

Express Mail Receipt No. EK618022351US
Date of Deposit 7-25-2000

Signature Robert Mulcahy

Respectfully submitted,


Robert Mulcahy
Registration No. 25,436